

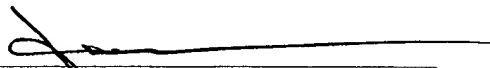


#16 DAC/3723
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PATENT
Docket No. 474082000700

CERTIFICATE OF HAND DELIVERY

I hereby certify that this correspondence is being hand filed with the United States Patent and Trademark Office in Washington, D.C. on August 6, 2002.


Jeffery F. McCuller

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of:

Tomohiro HASHII

Serial No.: 09/594,502

Filing Date: June 16, 2000

For: SEMICONDUCTOR WAFER
GRINDING METHOD

Examiner: Robert A. Rose

Group Art Unit: 3723

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OFFICE OF PETITIONS

**PETITION FOR REVIVAL OF AN APPLICATION FOR PATENT ABANDONED
UNDER 37 C.F.R. § 1.135(a) (PTO ERROR)**

Box DAC
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Applicant petitions for revival of the above-referenced application. It is believed that the Office has abandoned this application erroneously, for the following reasons.

Nature of abandonment:

- ☒ In an office communication from the PTO dated July 16, 2002, the undersigned has noted that the above-referenced application is being forwarded to the Abandoned Files because applicant's response to the Official Action mailed December 4, 2001, has not been received within the statutory period or any extension requested therefor.
- ☒ The undersigned has reviewed her records and noted that the response to the Official Action mailed December 4, 2001 was timely filed within the statutory period or any extension requested therefor.

This application became abandoned because the failure to prosecute, which determination is in error on the part of the Office.

A response to the Office Action of December 4, 2001:

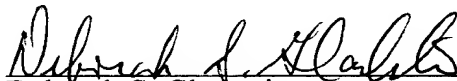
- ☒ was timely filed on April 1, 2002 under 37 C.F.R. § 1.111.
- ☒ a copy of the response filed is attached.
- ☒ a copy of the petition for extension of time filed with the response is attached.
- ☒ a copy of the postcard received from the Patent Office acknowledging receipt of the response is attached.
- ☒ a copy of a Notice of Abandonment is attached.

Applicant believes that no fee is due in connection with this Petition, due to the fact that this is a PTO error. However, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. §§ 1.16 and 1.17 that may be required by this petition, or to credit any overpayment, to **Deposit Account No. 03-1952.**

- ☒ I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application, any patent issuing thereon, or any patent to which this verified statement is directed.

Dated: August 6, 2002

By:


Deborah S. Gladstein
Registration No. 43,636

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Attorney Docket: 47408-20007.00 Date: April 1, 2002
Inventor(s): Tomohiro HASHII USSN: 09/594,502
Title: SEMICONDUCTOR WAFER GRINDING METHOD

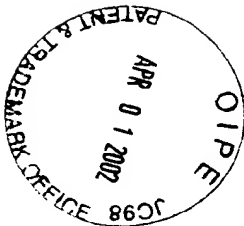
Papers enclosed: 1. Amendment
2. Petition for 1-Month Extension of Time
3. Postcard

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Prepared by: KRS/MAG

Attorney Docket: 47408-20007.00 Date: April 1, 2002
Inventor(s): Tomohiro HASHII USSN: 09/594,502
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Prepared by: KRS/MAG

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